



Attc.ney Docket No. ROH-039

5/2 action  
P. Walker  
3-31-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent Application of

Takashi Nakamura

Group Art Unit: 2818

Serial No. 09/856,818

Examiner: David Nhu

Filed: May 25, 2001

Confirmation No. 3701

FOR: METHOD OF FORMING INORGANIC COMPOUND SOLID AND METHOD OF  
MANUFACTURING SEMICONDUCTOR DEVICE EMPLOYING THE SAME

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action dated February 28, 2003, Applicant hereby elects  
Species I, claims 1-22, with traverse.

It is respectfully submitted that the subject matter of all claims is sufficiently related  
that a thorough search or the subject matter of any one group of claims would necessarily  
encompass a search for the subject matter of the remaining claims. Thus, it is respectfully  
submitted that the search and examination of the entire application could be made without  
serious burden. See MPEP 803 which is stated that "if the search and examination of an  
entire application can be made without serious burden, the examiner must examine it on the  
merits, even though it includes claims that are distinct or independent inventions".

It is respectfully submitted that this policy should apply to the present application in  
order to avoid unnecessary delay and expense to Applicants and the duplicative  
examination by the Patent Office. Receipt of the initial Office Action on the merits is awaited.

In the event that any additional fees are required with respect to this paper, the  
Commissioner is hereby authorized to charge our Deposit Account No.18-0013.

Respectfully submitted,

By:

  
Carl Schaukowitch  
Reg. No. 29,211

Date: 3/27/03

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